

/Robert Kunemund/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

03/02/2008

IN THE MATTER OF:

ART UNIT: 1792

Jaehwan EUN, et al

EXAMINER: Kunemund, Robert M.

SERIAL NO.: 10/539,883

CONFIRMATION NO.: 1957

FILED: June 17, 2005

FOR: Method For Preparation of Ferroelectric Single Crystal Film Structure Using
Deposition Method

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

S I R:

This is in response to the outstanding Office Communication dated
November 14, 2007. The Commissioner is authorized to charge any fees required in
the prosecution of this application to Deposit Account No. 503814.

Please amend the present application as follows: